

Title (en)

Apparatus and method for scattering particles in a particle board production

Title (de)

Vorrichtung und Verfahren zum Zerstreuen von Partikeln in einer Spanplattenproduktion

Title (fr)

Appareil et procédé de diffusion de particules dans une production de panneaux de particules

Publication

EP 2626179 B1 20150513 (EN)

Application

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Priority

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Abstract (en)

[origin: EP2626179A1] The invention relates to an apparatus for scattering particles for forming particle mats in a particle board production process, the apparatus having a source (1) for supplying particles to at least one roller array (7) for spreading the particles onto a mat conveyor (10), wherein an airflow for scattering the particles onto the at least one roller array (7) is provided above the uppermost roller array (7). Further, the invention relates to a method for scattering particles for forming particle mats in a particle board production process.

IPC 8 full level

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